



**ELECTRONIC COPY**

LG778690081  
Report verification at igi.org



February 27, 2026  
IGI Report Number **LG778690081**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **7.96 X 5.80 X 3.64 MM**  
**GRADING RESULTS**  
Carat Weight **1.07 CARAT**  
Color Grade **E**  
Clarity Grade **VS 2**

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**GRADING RESULTS**

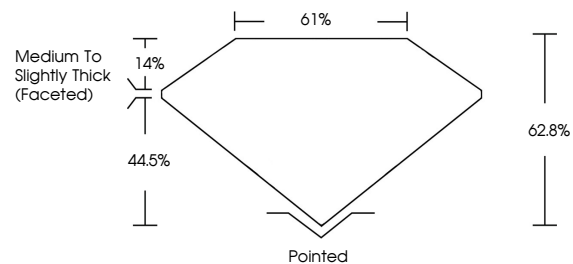
Carat Weight **1.07 CARAT**  
Color Grade **E**  
Clarity Grade **VS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG778690081**

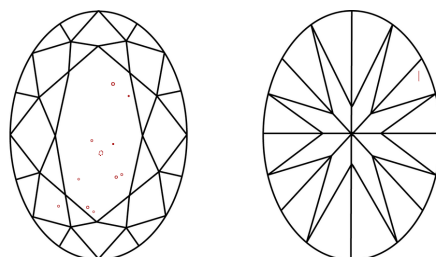
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

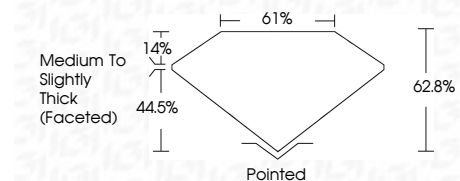
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**

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**OVAL BRILLIANT**  
7.96 X 5.80 X 3.64 MM  
1.07 CARAT  
Color Grade **E**  
Clarity Grade **VS 2**  
Depth **62.8%**  
Table **61%**  
Girdle **Medium to Slightly Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG778690081**

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